

DOCKET: CU-3589

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Masahiro Sunohara et al.

Serial No.: 10/781,416

Group Art Unit: 2812

Filed: February 18, 2004

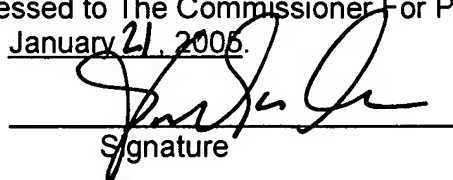
Examiner:

For: Semiconductor Device Fabrication Method

Certification under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 21, 2005.

W. William Park, Reg. No. 55,523
Name


Signature

THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

**RE-TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT FILED ON
JANUARY 11, 2005 AND WITHIN THREE MONTHS OF FILING OR BEFORE
MAILING OF FIRST OFFICE ACTION**

This is a re-transmittal of the information disclosure statement already filed January 11, 2005 to correct an inadvertent typographical error in the PTO-1449 form, which a Japanese Reference No. "59-152639" was inadvertently written as "59-152693"

This information disclosure statement submitted herewith will replace the earlier filed information disclosure statement and is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of the first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(b).

No fee is believed to be required in view of the above. However, if this not the case, the Commissioner is authorized to charge Deposit Account No. 12-0400 for any required fees.

Date: January 21, 2005



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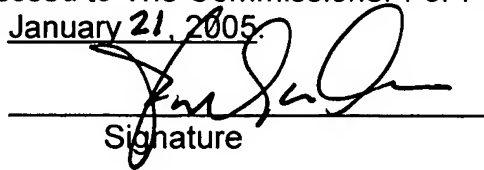
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THE COMMISSIONER FOR PATENTS

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Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants submit herewith patents, publications or other information of which the applicants are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose under 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

The references submitted herein are listed on PTO-1449 form (modified) enclosed herewith. A copy of each reference listed is being furnished except any duplicate or cumulative patents or publications specified otherwise.

A translation of any foreign language reference, if any, is indicated in PTO-1449 form and being submitted herein if it is readily available. Otherwise it should be construed that such translation is not readily available.

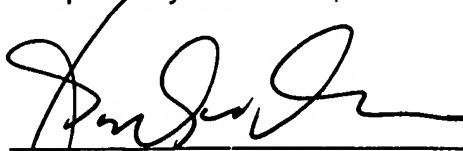
The USPTO rules has recently been revised such that IDS's for applications filed after June 30, 2003 do not need to include paper copies of the US patent references. Accordingly, no paper copies of the U.S. patent references identified in this IDS are submitted herewith since the filing date of the present application is after June 30, 2003. Only the copies of foreign patent and/or other relevant publication references are submitted herewith.

Also submitted herein is a copy of the European Search Report which satisfies the requirement for a translation or concise explanation of any non-English reference cited therein, as provided in MPEP §609 A(3). Nevertheless, an English Abstract is attached to each non-English reference.

The Statement is made on the basis of the information:

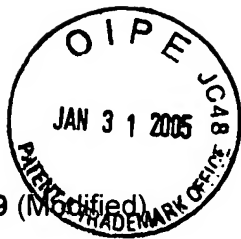
<u> </u>	supplied by the inventor(s);
<u> X </u>	supplied by an individual associated with the filing and prosecution of this application (37 CFR 1.56(c));
<u> X </u>	cited in a corresponding EPO application; or
<u> </u>	in the attorney's file.

Respectfully submitted,



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Date: January 21, 2005



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Form PTO-1449 (Modified)

FORM PTO-1449	ATTY. DOCKET NO. CU-3589	SERIAL NO. 10/781,416
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	APPLICANT Masahiro Sunohara et al.	
(37 CFR 1.98(b))	FILING DATE February 18, 2004	GROUP 2812

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER							ISSUE DATE	PATENTEE	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
	2002		0	2	5	6	5	6	02-28-02	Arai et al.			
		5	3	6	2	6	8	1	11-08-94	Roberts et al.			

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

EXAMINER INITIAL		DOCUMENT NUMBER							PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB- CLASS	TRANSLATION YES NO	
	59		1	5	2	6	3	9	08-31-84	Japan				
	198			1	1	1	1	5	09-16-99	Germany				
	2000		2	9	9	2	9	7	10-24-00	Japan				
	2003			8	6	5	4	0	03-20-03	Japan				

OTHER DOCUMENTS (Including Author, Title, Date, Place of publication)

EXAMINER	DATE CONSIDERED		
<p>EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>			

(Form PTO-1449)